

Electronic Patent Application Fee Transmittal

Application Number:	10694986			
Filing Date:	29-Oct-2003			
Title of Invention:	METHOD FOR REMOVING RESIST PATTERN AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE			
First Named Inventor/Applicant Name:	Masaharu Nagai			
Filer:	John F. Hayden/April Saunders-Fuller			
Attorney Docket Number:	12732-0171001			
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Patent-Appeals-and-Interference:				
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